



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

August 5, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG825699087

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

7.82 - 7.88 X 4.63 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

1.75 CARAT

D

VS 1

EXCELLENT

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

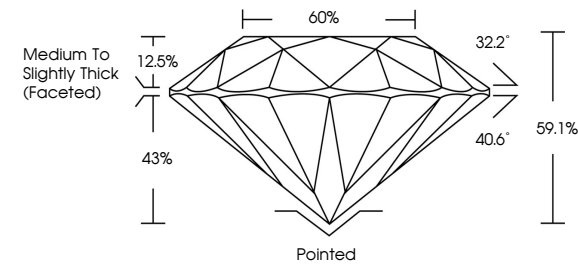
EXCELLENT

NONE

IGI LG825699087

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Medium To Slightly Thick (Faceted)

60%

32.2°

40.6°

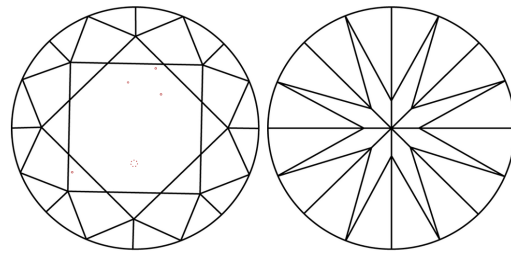
59.1%

43%

12.5%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included



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IGI

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IGI Report No LG825699087

ROUND BRILLIANT

7.82 - 7.88 X 4.63 MM

Carat Weight

Color Grade

Clarity Grade

Cut Grade

Depth

Table

Girdle

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

1.75 CARAT

D

VS 1

EXCELLENT

59.1%

60%

Medium To Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

IGI LG825699087

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